

NANOSTRUCTURED OPTICS

With transparencies from

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- Frank Brückner
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- Oliver Burmeister
- Daniel Friedrich
- Bernard Kley
- Roman Schnabel

Harald Lück, AEI





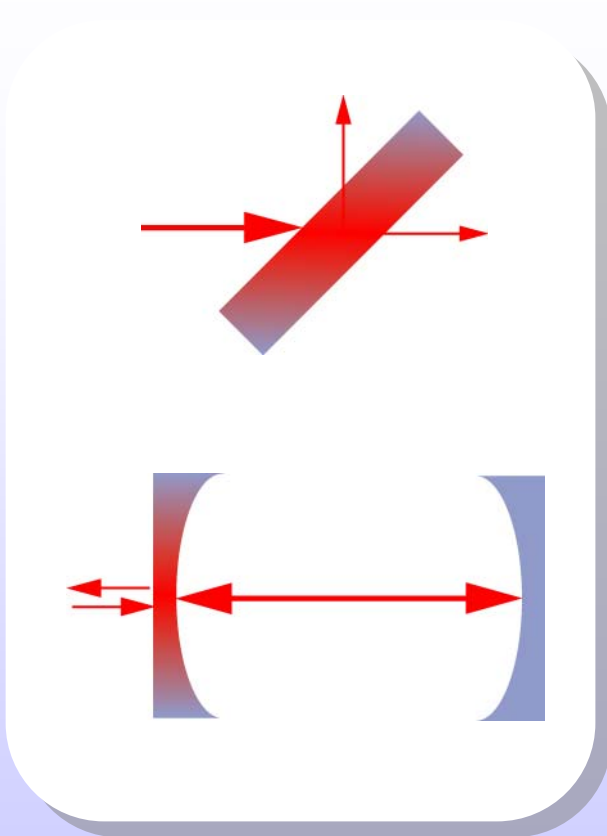
Gratings in Interferometers



- Gratings as cavity mirrors
 - 1st order Litrow
 - 2nd order Litrow
- Gratings as Beam Splitter
- Waveguide Coatings

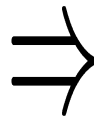


transmissive Optics

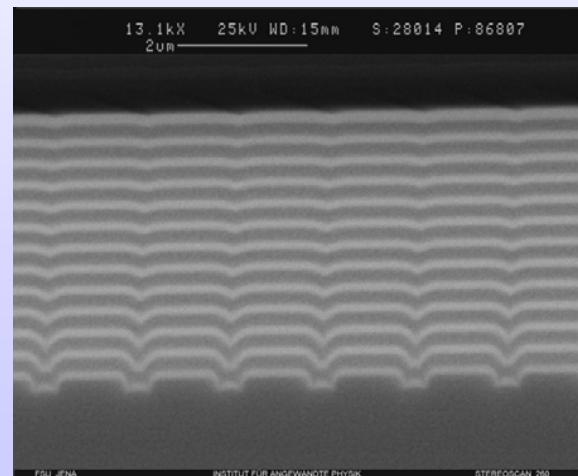
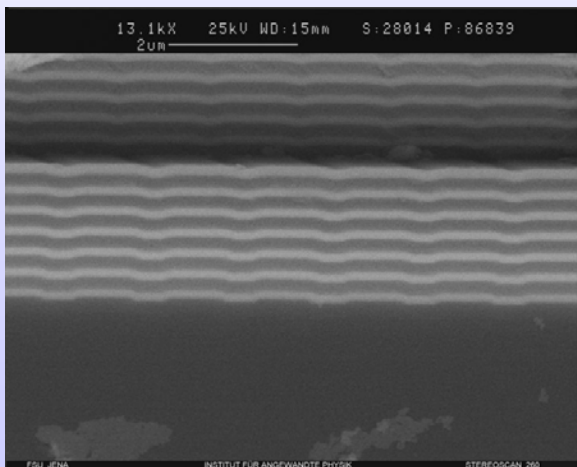
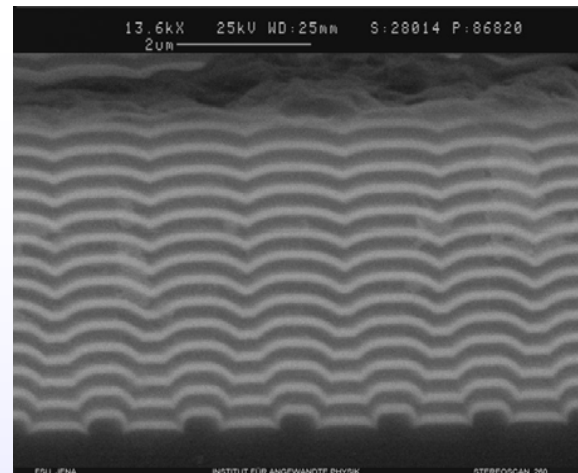
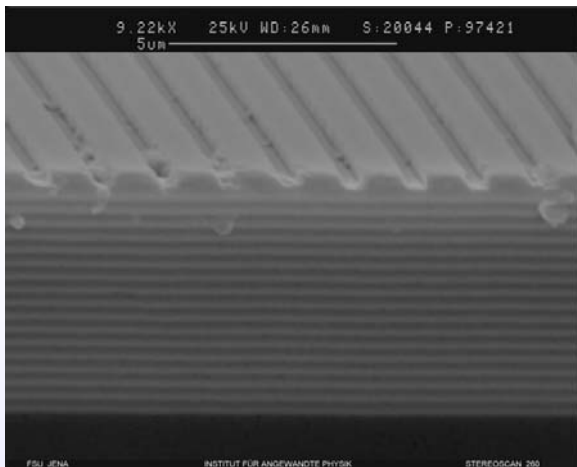


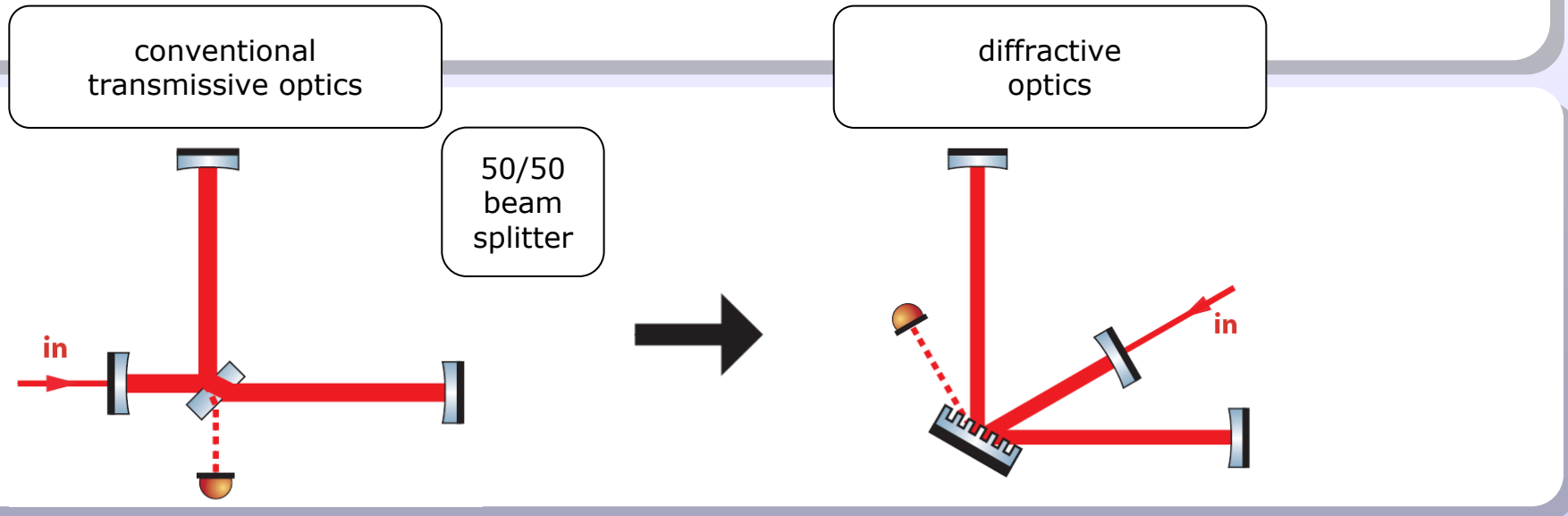
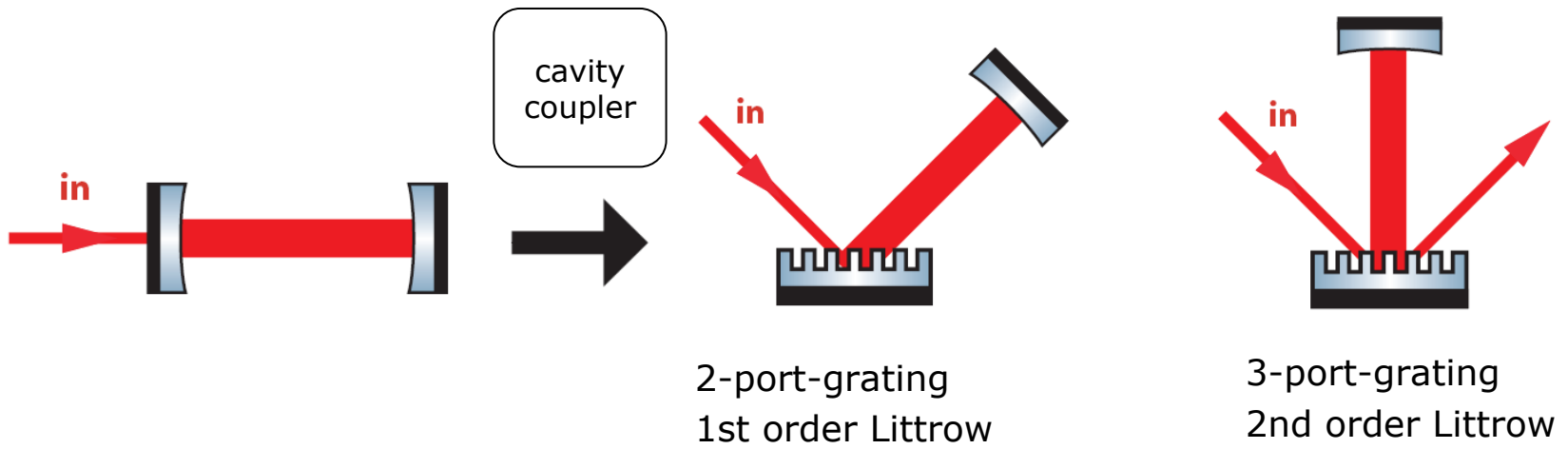
Thermal Effects from Absorption

- Thermal Lensing
- Thermal deformation
- Thermal effects limit power



Avoid Transmission using reflective optics







Option 1:

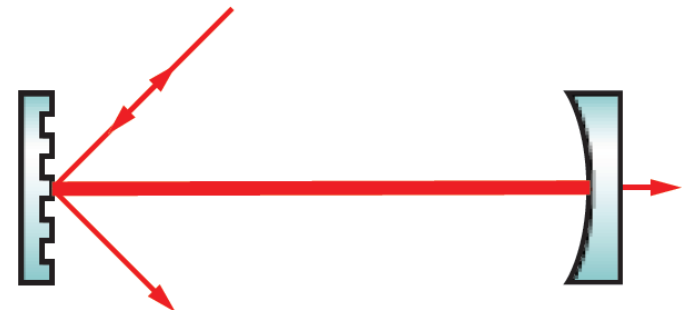
1st order Littrow mount



- Input light enters via the 1st diffracted order path
- Grating = 2 port device
- Requires high efficiency, low loss grating

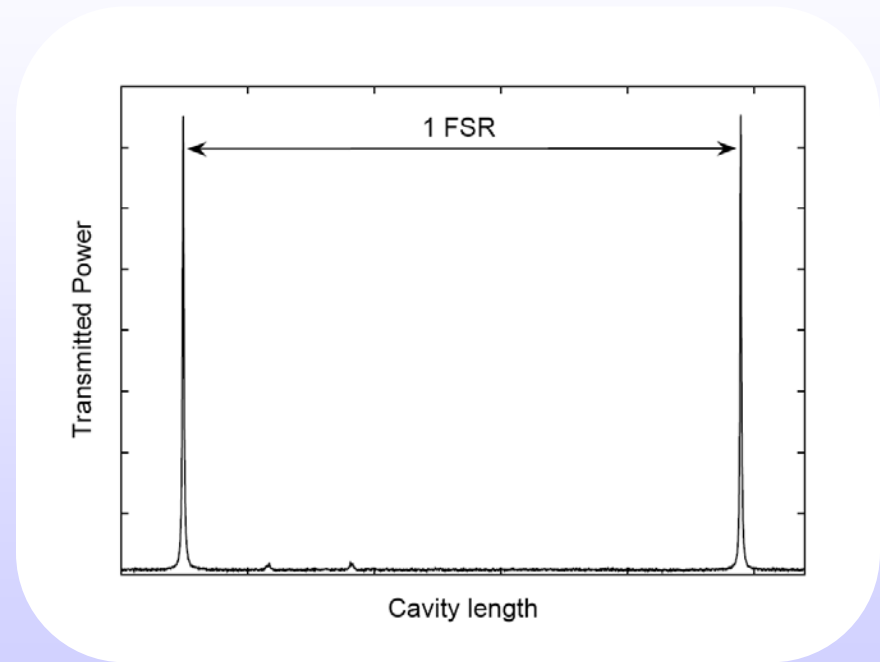
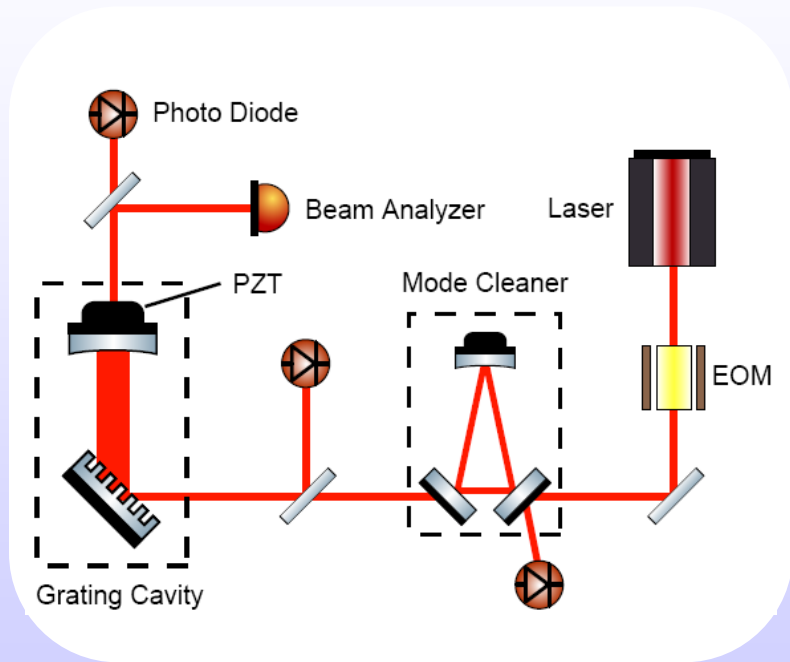
Option 2:

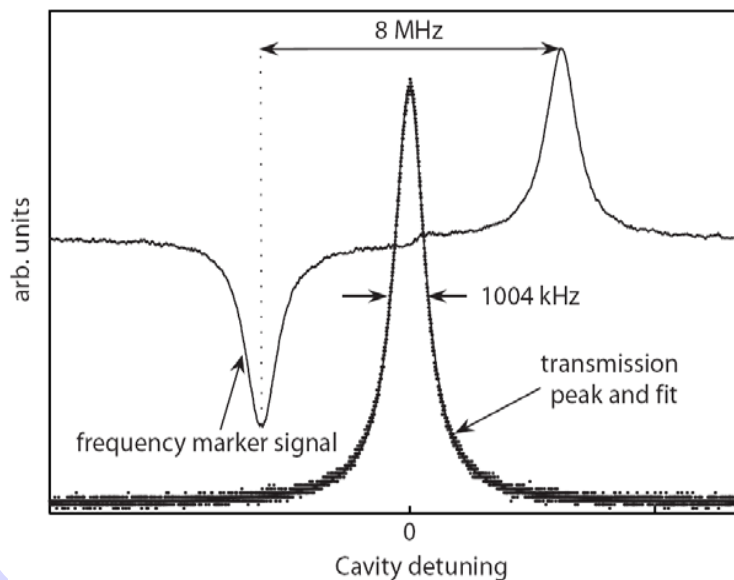
2nd order Littrow mount



- Input light enters via the 2nd diffracted order path
- 1st order is normal to the grating surface
- Grating = 3 port device
- Requires low 1st order efficiency, low loss grating

1st order Littrow cavity





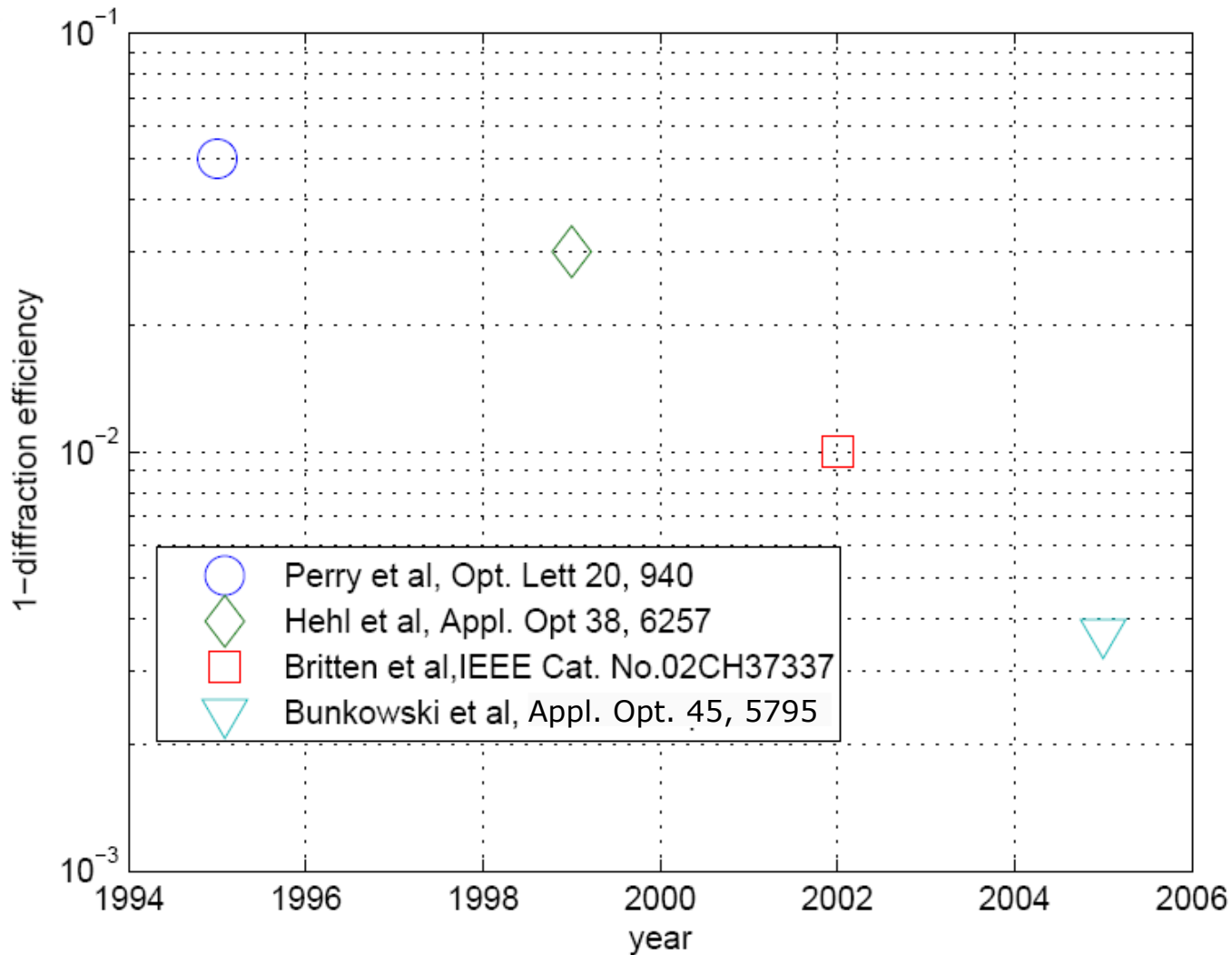
Results:

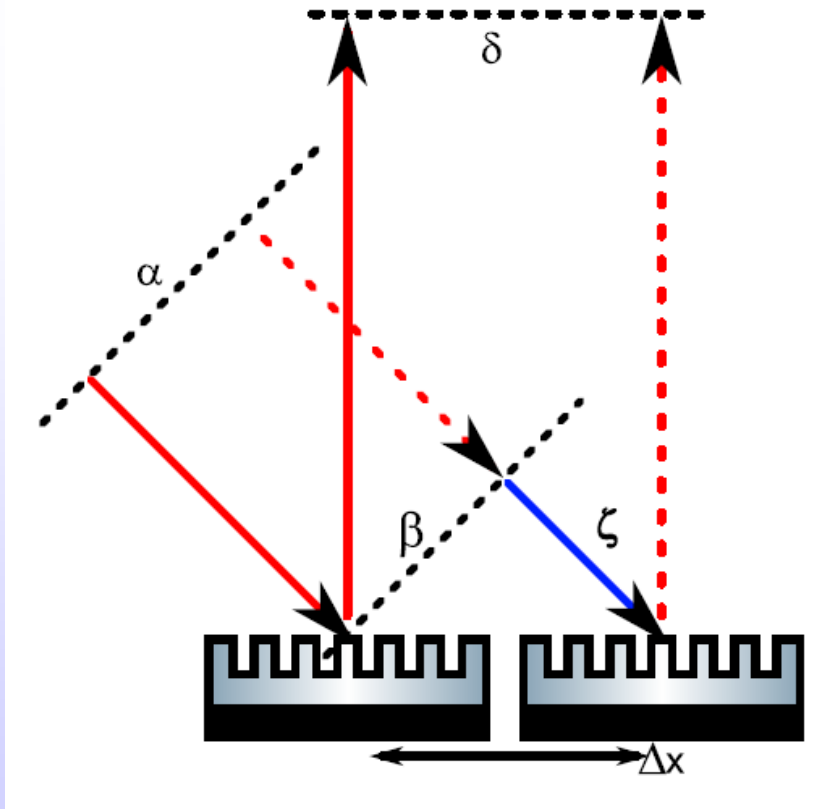
Finesse: 1580 ± 60

Diffr. eff.: $99.63\% \pm 0.02\%$

Loss: 0.19%

Bunkowski et al.

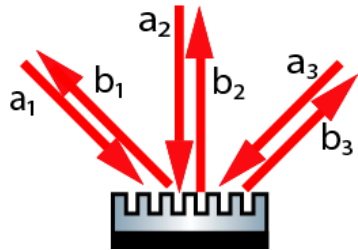




Well known effect,
e.g. in acousto-optic
Modulators

Phase of diffracted
beam changes with
lateral motion
between the beam
and the grating

Discussed in: J. Hallam, J. Hallam
Hallam et al., arXiv:0903.3324v2 [gr-qc] 5 May
2009

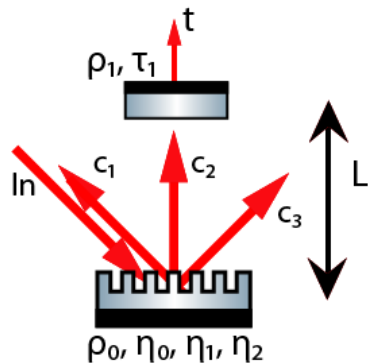


- Scattering-matrix-formalism
- Phases depend on diffraction efficiencies
- Non vanishing matrix elements

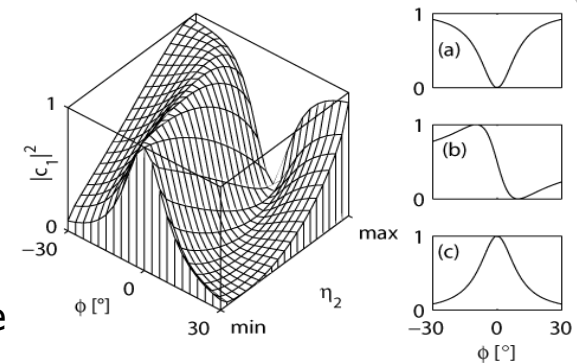
$$\mathbf{b} = \mathbf{S} \times \mathbf{a}$$

$$\mathbf{S}_{3p} = \begin{pmatrix} \eta_2 e^{i\phi_2} & \eta_1 e^{i\phi_1} & \eta_0 e^{i\phi_0} \\ \eta_1 e^{i\phi_1} & \rho_0 e^{i\phi_0} & \eta_1 e^{i\phi_1} \\ \eta_0 e^{i\phi_0} & \eta_1 e^{i\phi_1} & \eta_2 e^{i\phi_0} \end{pmatrix}$$

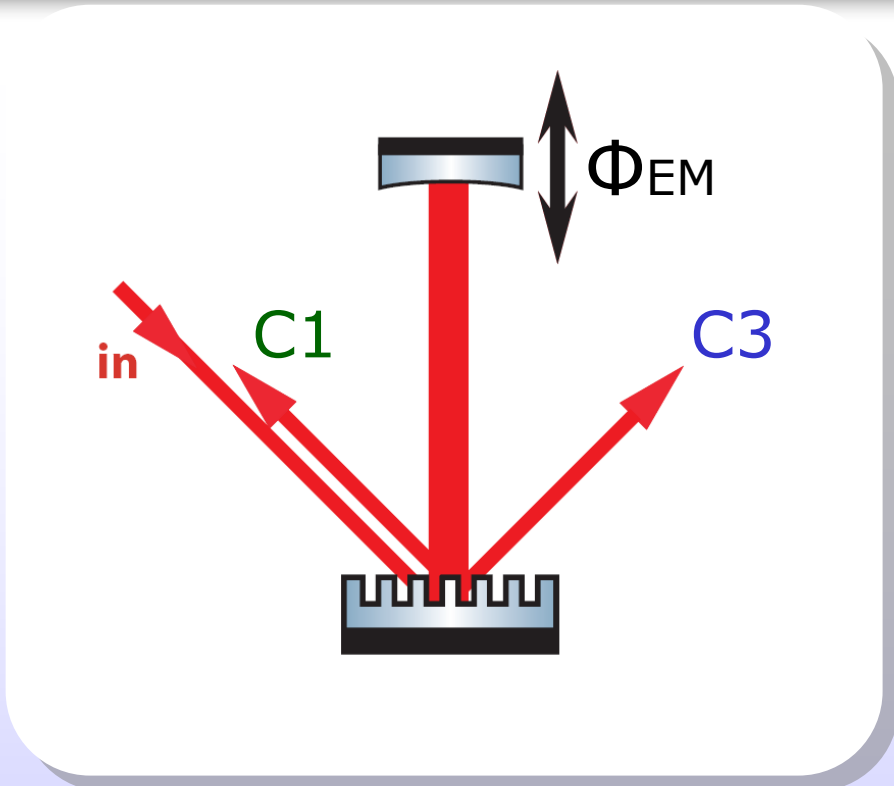
$\eta_n \neq 0$



- Coupling to an optical resonator via 1st diffraction order
- Low diffraction efficiency η_1 / high reflectivity ρ_0
- Two reflection ports c_1/c_3
- Grating design defines ratio of the radiation at the output ports

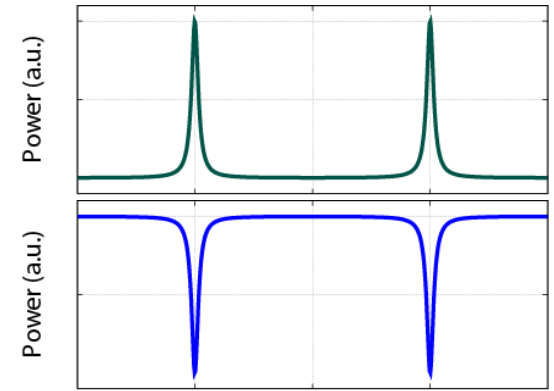


Opt. Lett. 29, 2342 (2004), Opt. Lett. 30, 1183 (2005),
Opt. Lett. 31, 658 (2006), Opt. Lett. 31, 2384 (2006)



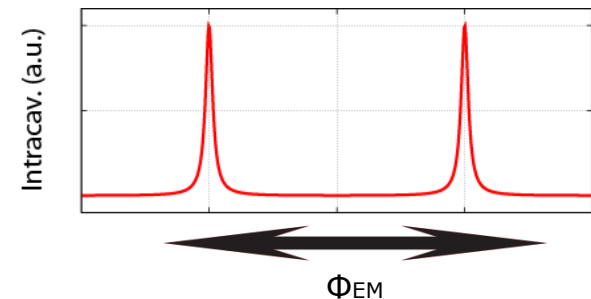
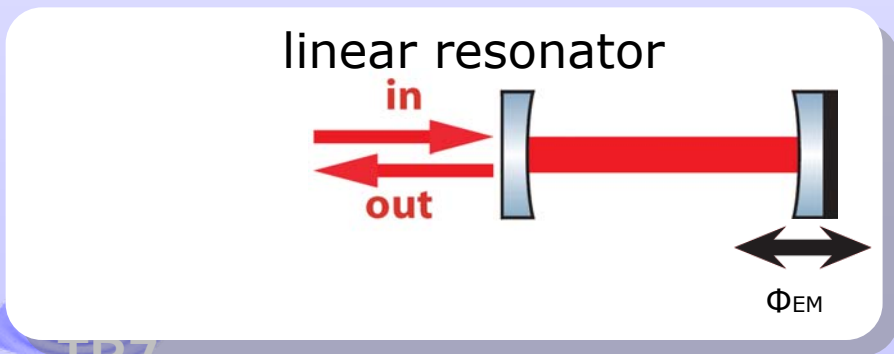
η_{2min} -configuration

Port C1

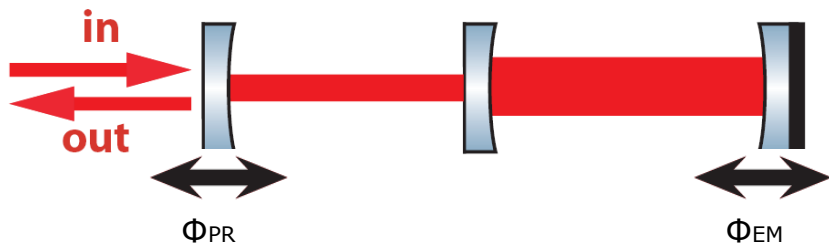
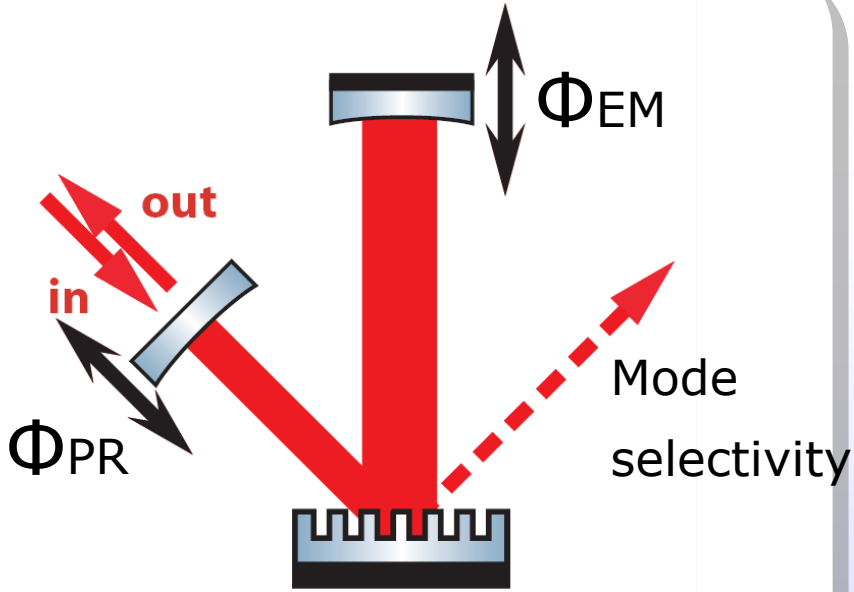


Port C3

- Resonant light reflected towards laser
- Modeselective mirror
- One degree of freedom (Φ_{EM})

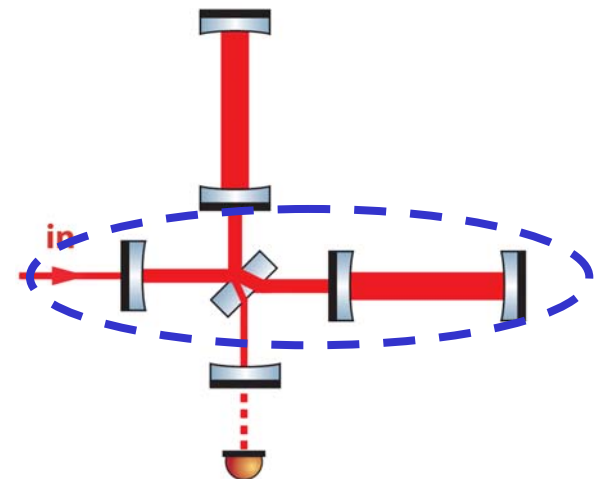


G0900612-v1

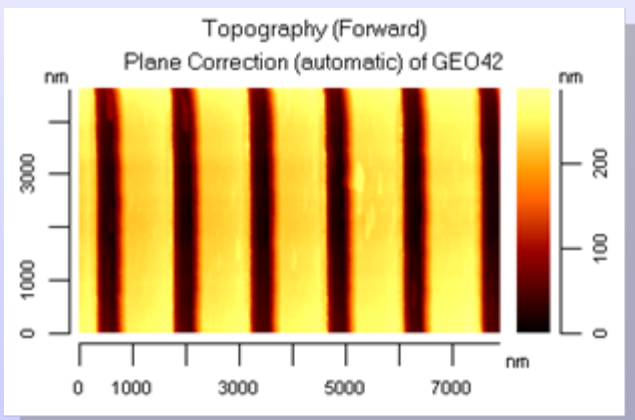
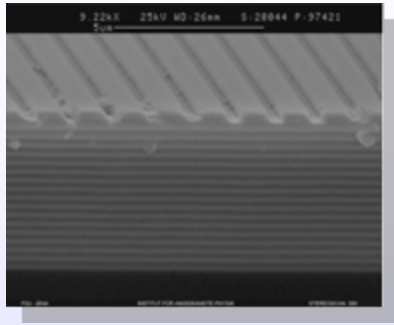
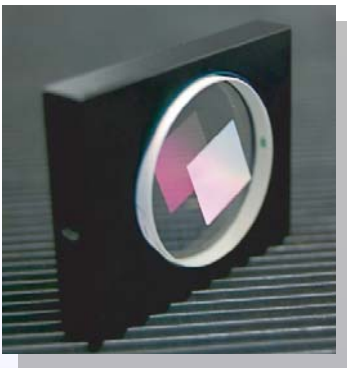


Power-recycling

- Power-recycling mirror (M_{PR}) in reflection port C1
- Additional power build-up in the grating cavity
- Grating-coupled double-resonator
- Two degrees of freedom (Φ_{EM} , Φ_{PR})



G0900612-v1



Grating GEO42



- Fused silica substrate
- HR-coating beneath grating structure
- $d=1450\text{nm}$ / fill factor 0.47
- Efficiencies:

$$\eta_0^2 = 92.368\%$$

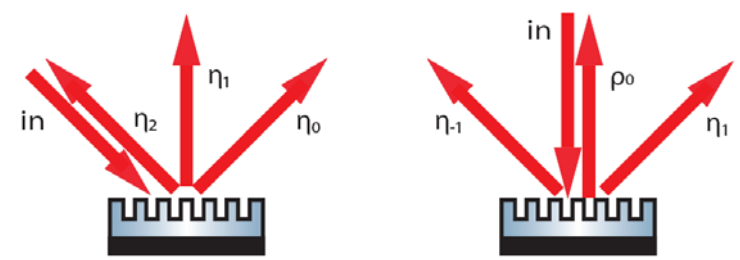
$$\eta_1^2 = 5.914\%$$

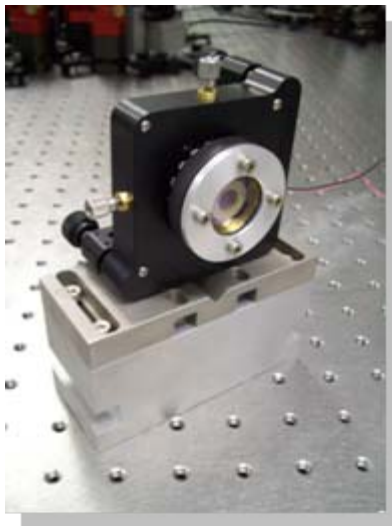
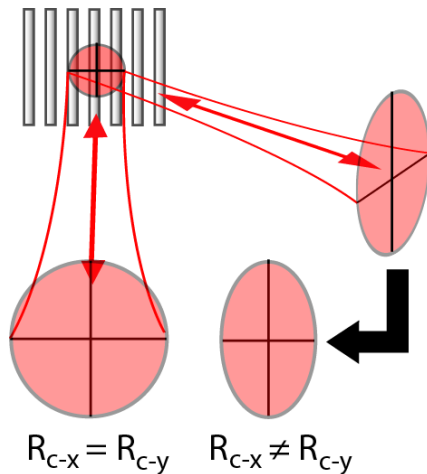
$$\eta_2^2 = 0.096\%$$

$$\rho_0^2 = 87.904\%$$

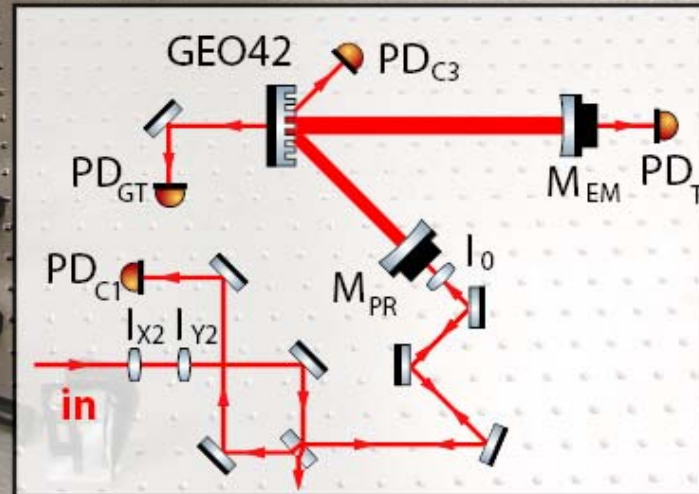
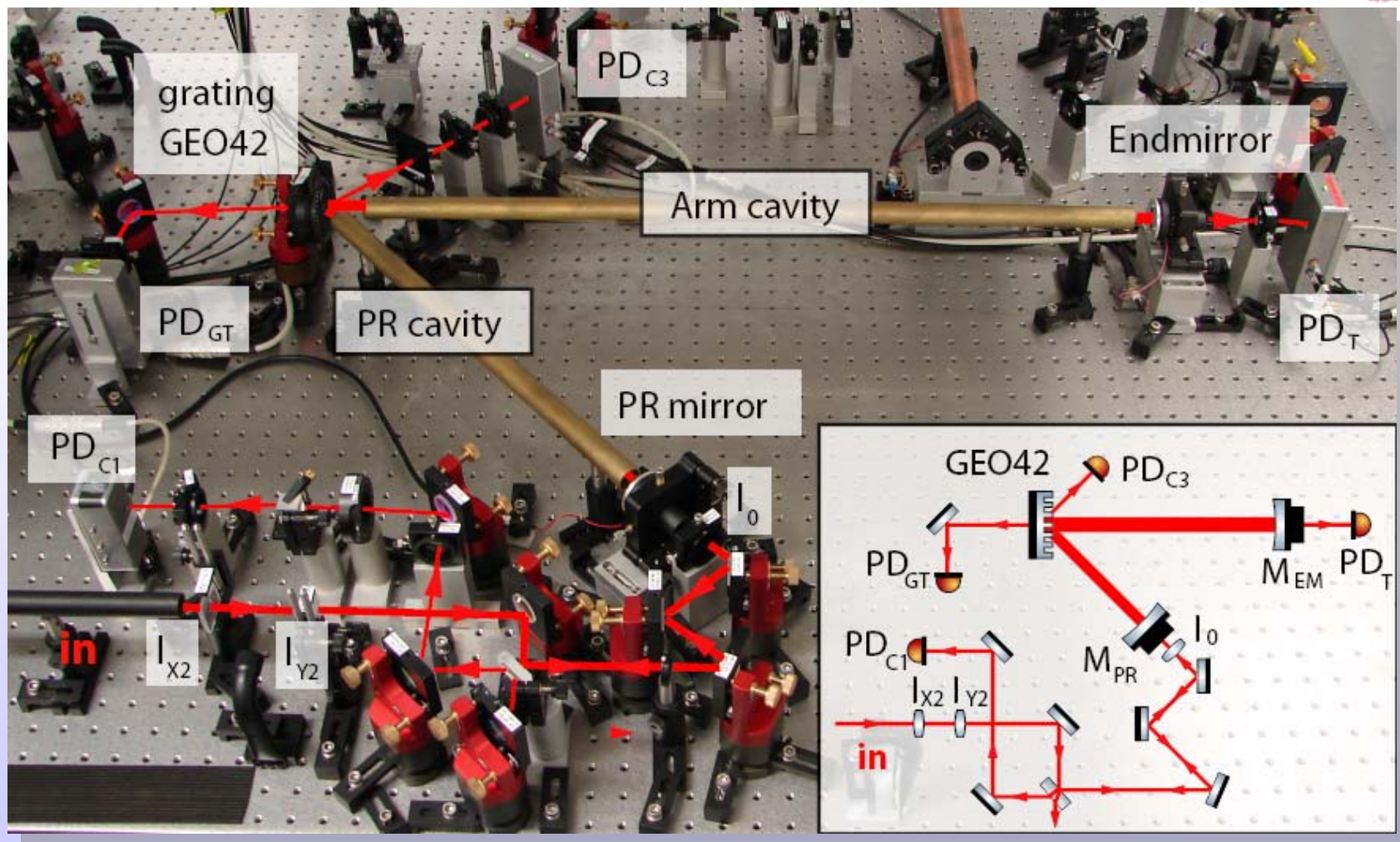
$$\tau_0^2 = 0.013\%$$

$$\text{Loss} = 0.268\%$$





- Elliptical beam profile due to different diffraction angles
- Modematching in two dimensions (cylindrical lenses)
- PR-mirror with two different radii of curvature (toroidal mirror)



Power build-up in arm w.r.t. input : ca. 300 (Britzger)

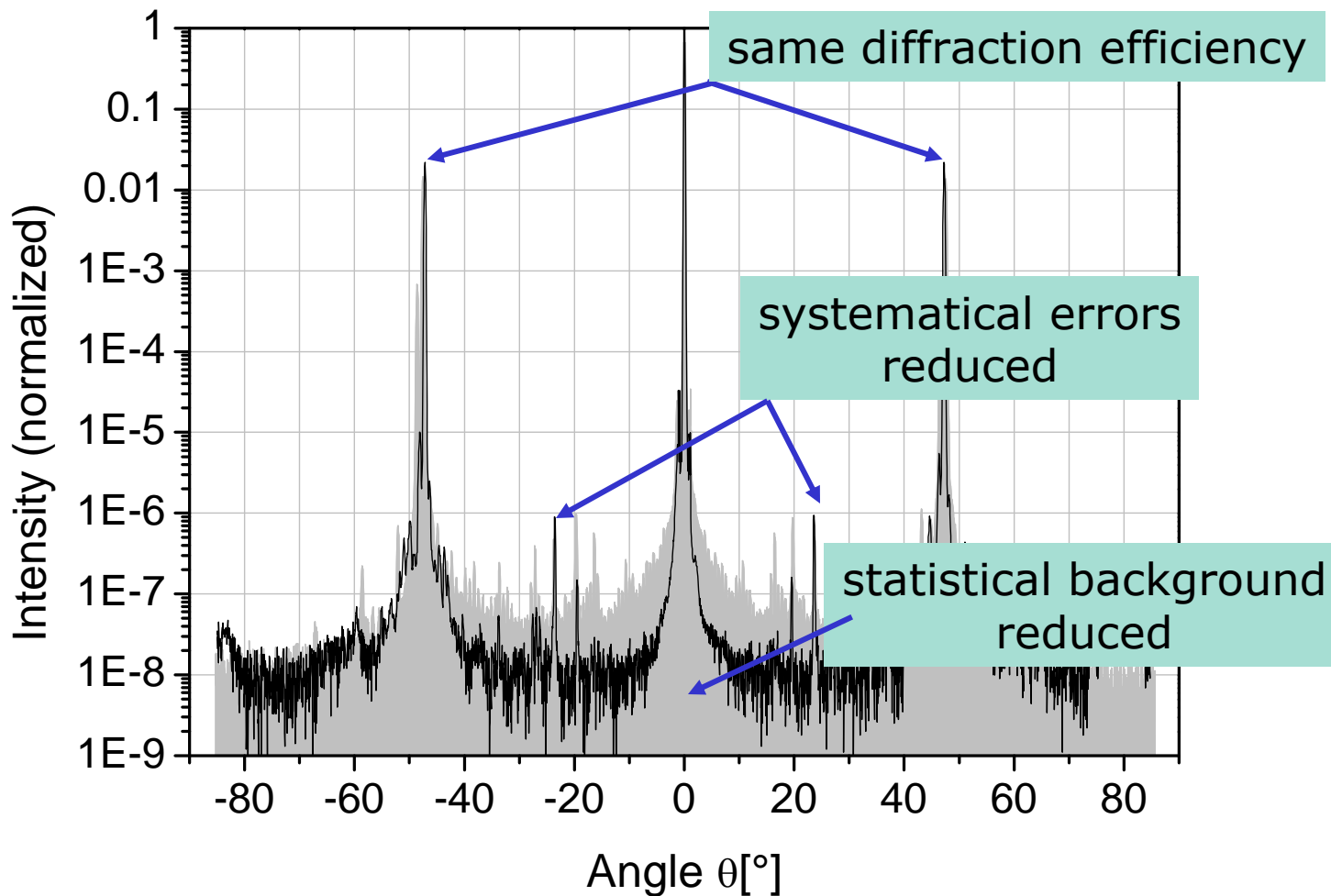
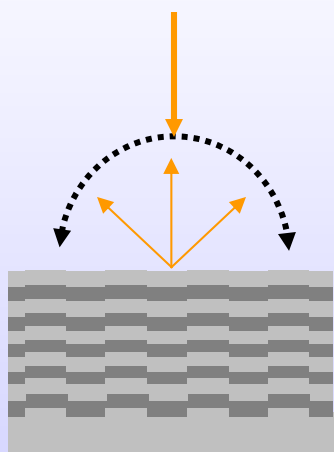
G0900612-v1



Small fill factor



groove depth 40nm
fill factor 50%



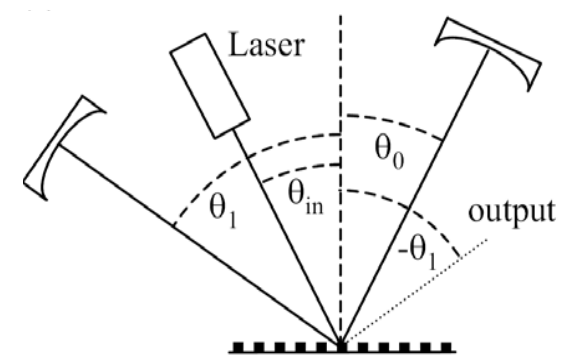
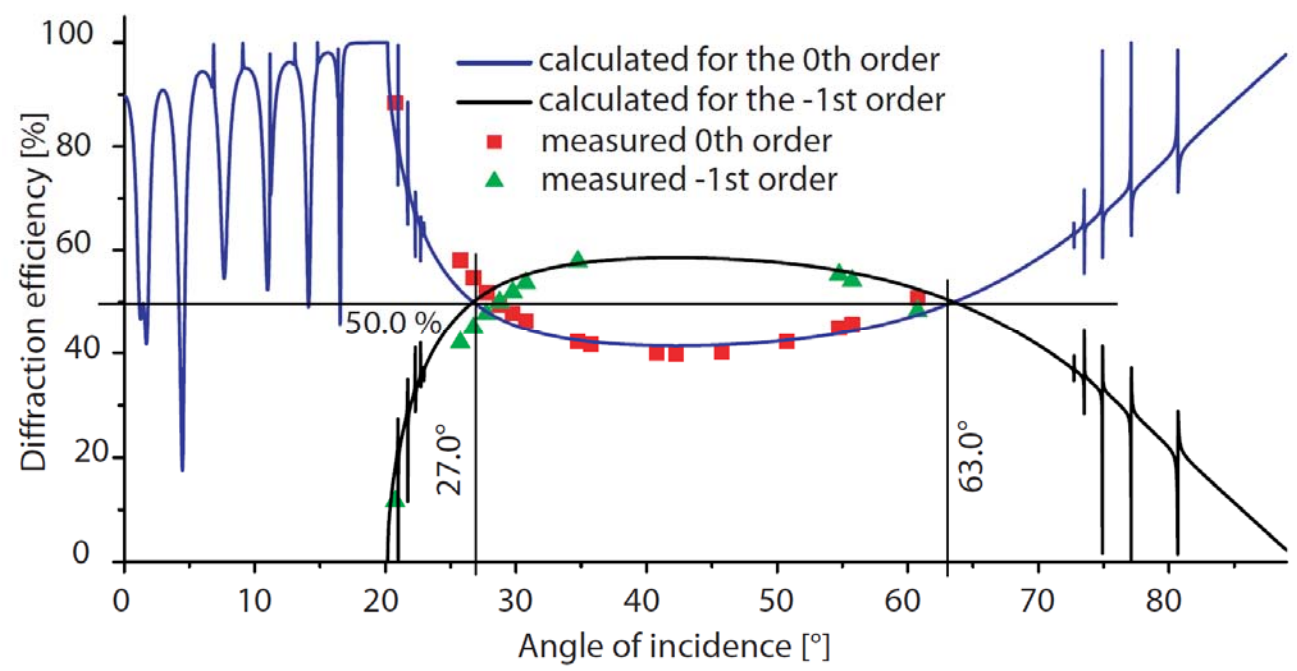
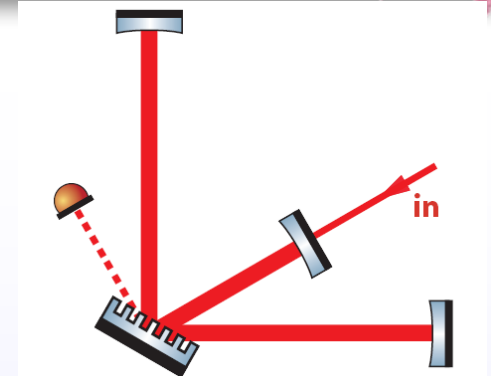


- Grating changes dielectric stack performance. Hard to predict
- Stack changes grating performance hard to predict
- Grating manufacturing process improvements
-> less scattering -> over coating will probably not be used in the future

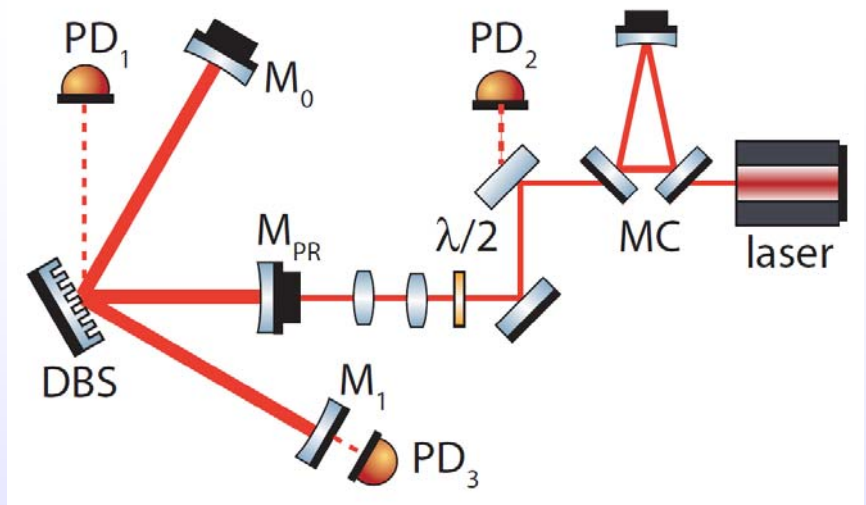
50/50 beamsplitter



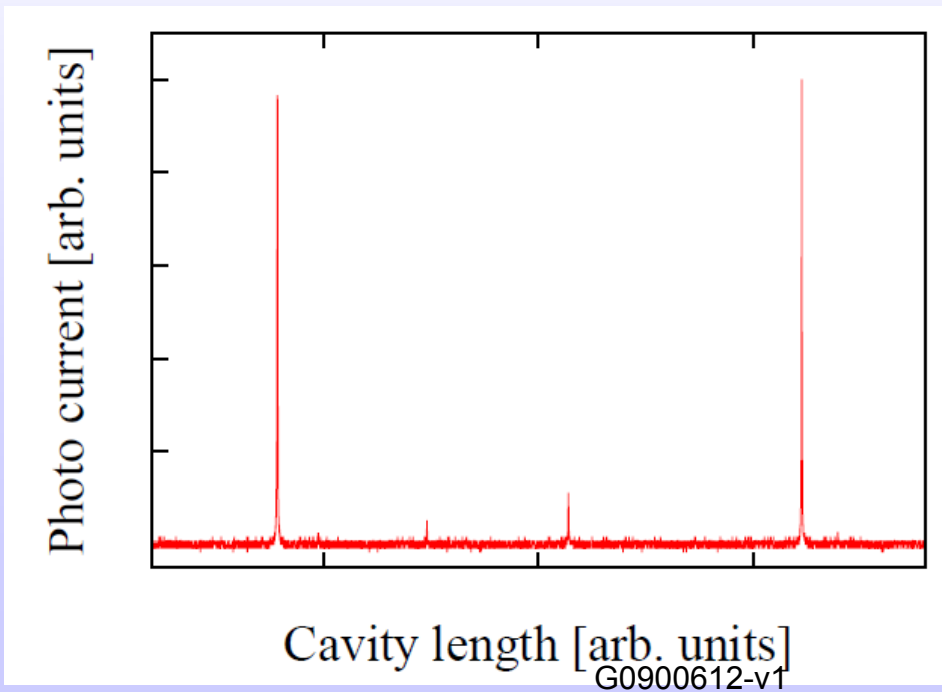
- Interesting for GEO-like ifos,
- since full power at BS

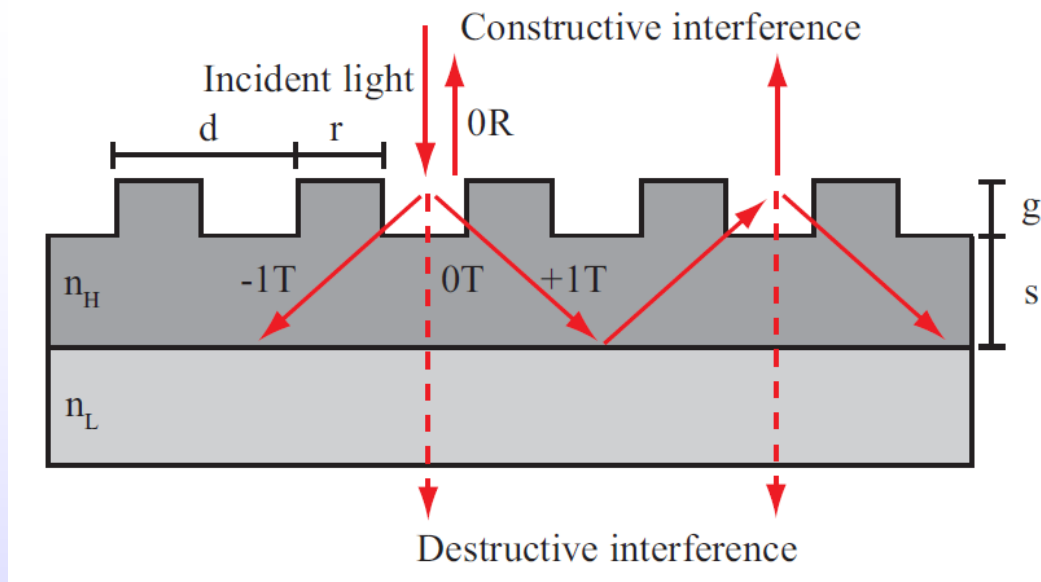


Friedrich et al., Journal of Physics: Conference Series **122** (2008) 012018



Finesse PRC ~ 880
Intra cavity losses 0.46%





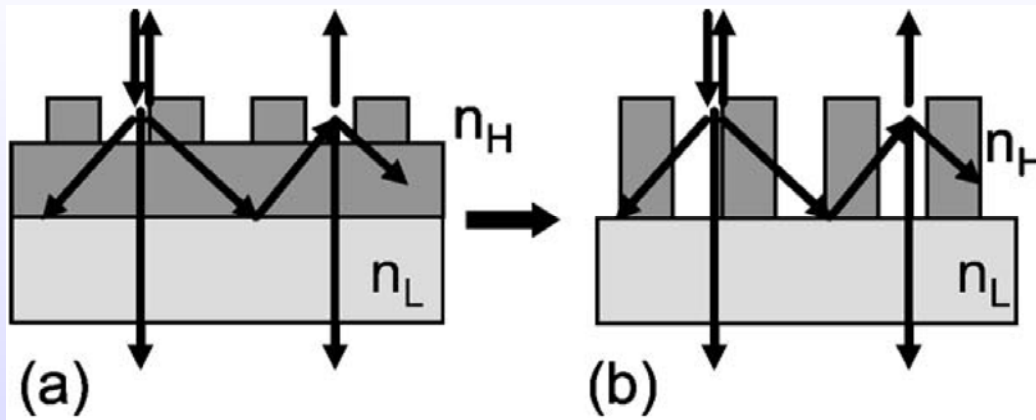
$$d < \lambda \quad (\text{to permit only zeroth order in air}),$$

$$\lambda/n_H < d \quad (\text{first orders in high-index layer}),$$

$$d < \lambda/n_L \quad (\text{only zeroth order in the substrate})$$



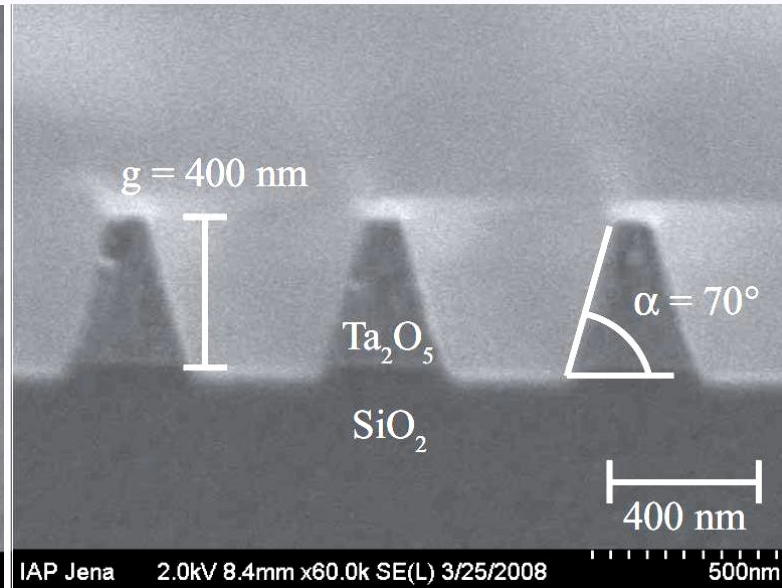
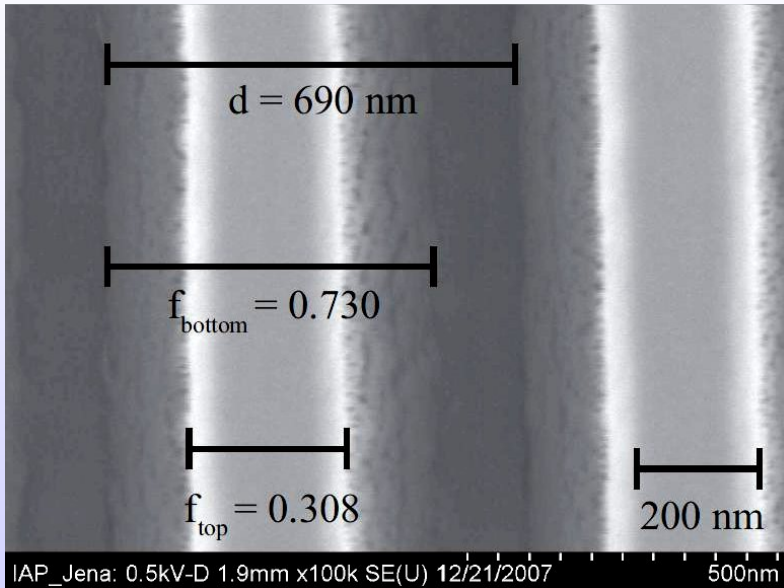
- Reduce the waveguide to the grating itself and still fulfil conditions for waveguiding
- Replace intuition by solving Maxwell equations for optimization



Monolithic 100% reflection "coating"
 [Brückner *et al.*, Opt. Lett., 33, 264 (2008)]



Compound structure $\text{SiO}_2 / \text{Ta}_2\text{O}_5$

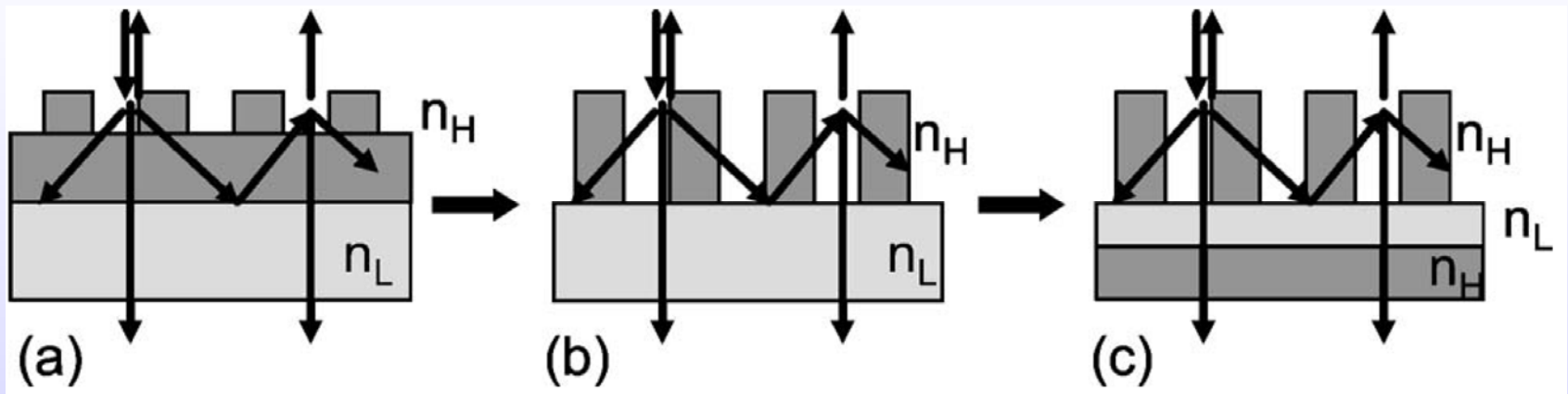


99.1% reflectivity realized:

Brückner *et al.*, OPTICS EXPRESS, **17**, No. 1, pp. 163---, (2009)

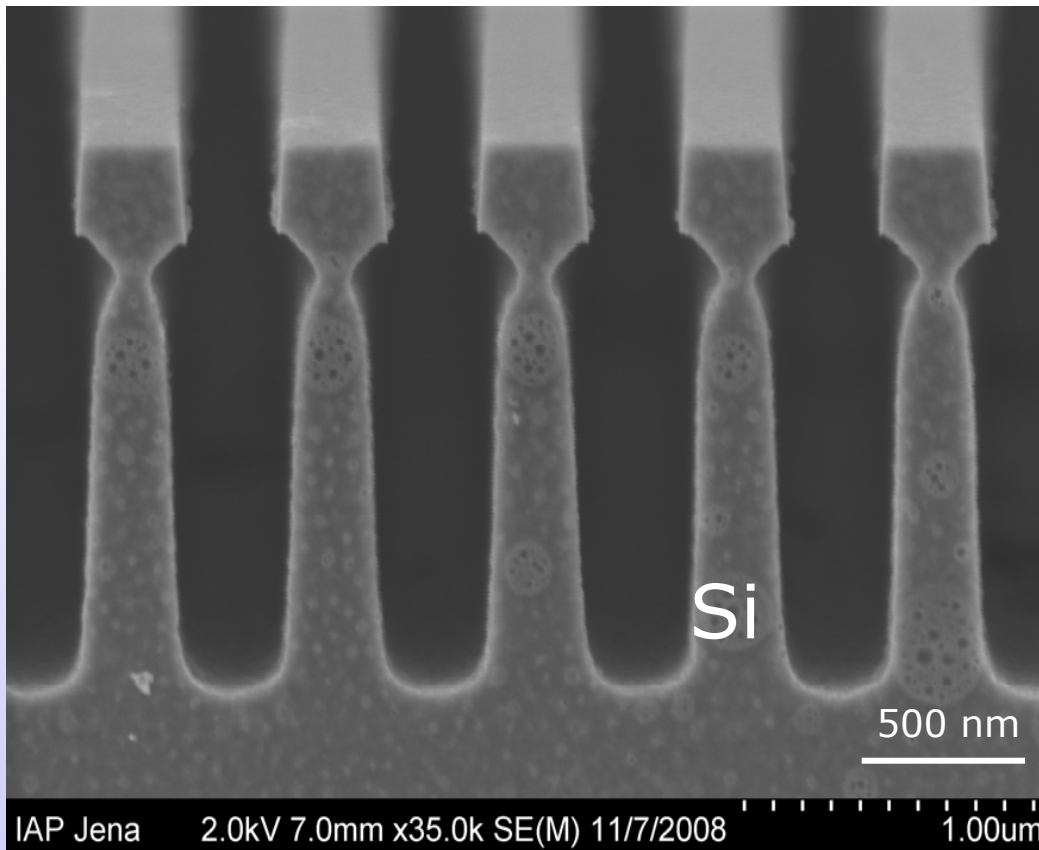
Contrast enhanced
for better visibility





Monolithic 100% reflection "coating"
 [Brückner *et al.*, *Opt. Lett.*, 33, 264 (2008)]





R > 99.8%, private communication, Brückner via Schnabel



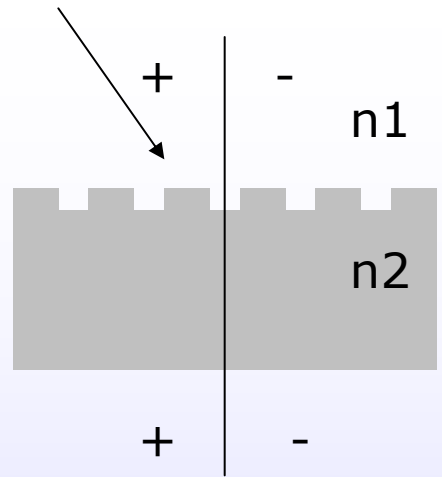


Application	Performance
Littrow 1st order	Efficiency 99.6%
Littrow 2nd order	Finesse 1580
BS	Losses 0.46%
Wave-guide coating	Reflectivity >99.8%



The arguments:

- Symmetry of the problem
- rigorous calculation shows no phase change
- Diffraction order changes sign

+ -

n1

+ -

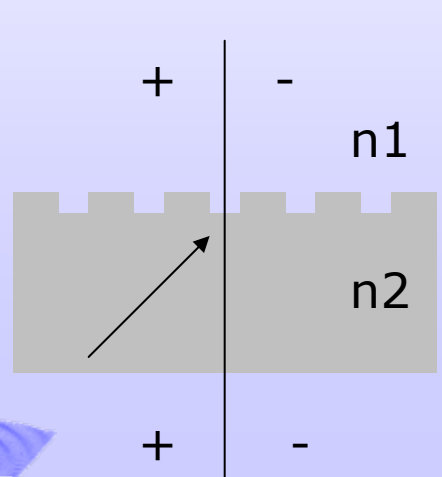
n2

+ -

Light coming from Superstrate

Refl.: $n1 \cdot \sin(\text{out}) + n1 \cdot \sin(\text{in}) = mL/d$

Trans.: $n2 \cdot \sin(\text{out}) + n1 \cdot \sin(\text{in}) = mL/d$



+ -

n1

+ -

n2

+ -

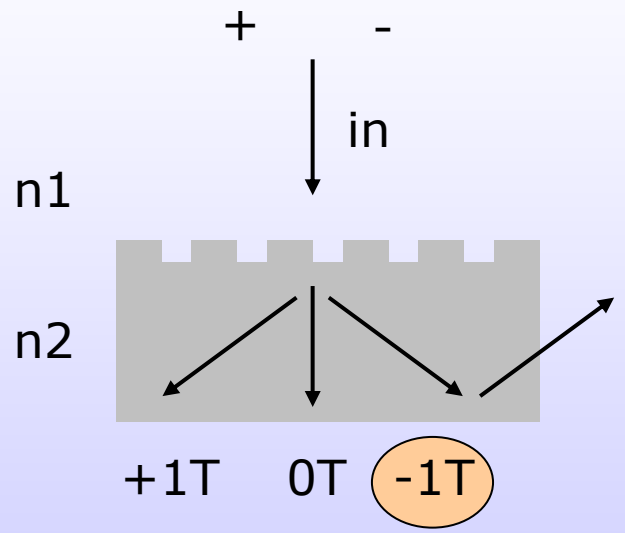
Light coming from Substrate

Refl.: $n2 \cdot \sin(\text{out}) + n2 \cdot \sin(\text{in}) = mL/d$

Trans.: $n1 \cdot \sin(\text{out}) + n2 \cdot \sin(\text{in}) = mL/d$

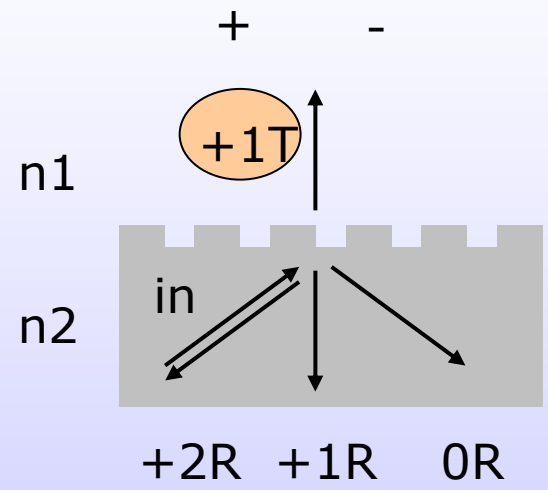


Trans.: $n_2 \sin(\text{out}) + n_1 \sin(\text{in}) = m\lambda/d$



Refl.: $n_2 \sin(\text{out}) + n_2 \sin(\text{in}) = m\lambda/d$

Trans.: $n_1 \sin(\text{out}) + n_2 \sin(\text{in}) = m\lambda/d$



-> Between coupling in and out the sign of the diffraction order switches